



Atty. Dkt. No. 047071-0109

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Henry A. ATWATER et al.
Title: WAFER BONDED EPITAXIAL TEMPLATES
FOR SILICON HETEROSTRUCTURES
Appl. No.: 10/784,586
Filing Date: 2/23/2004
Examiner: S. Ahmed
Art Unit: 1765
Conf. No.: 9646

**RESPONSE TO RESTRICTION REQUIREMENT
AND PRELIMINARY AMENDMENT UNDER 37 CFR 1.115**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Restriction Requirement dated June 23, 2006 and prior to examination of the present Continuing Application, Applicant respectfully requests that the application be amended as follows:

Amendments to the Specification begin on page 2 of this document.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this document.

Remarks/Arguments begin on page 5 of this document.

Please amend the application as follows: